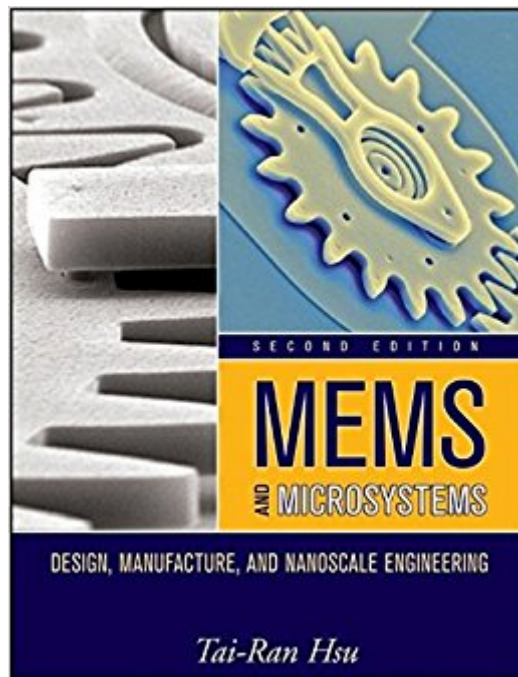




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MEMS And Microsystems: Design, Manufacture, And Nanoscale Engineering



Synopsis

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Tai-Ran Hsu, PhD, is a Professor in the Department of Mechanical and Aerospace Engineering, San Jose State University, California. Dr. Hsu is the author of the earlier edition of this book, which is considered one of the bestselling textbooks on the subject of MEMS.

nice book.

Good

Required for a class. I would have not bought otherwise. Full of mistakes and ambiguous wording. A nice waste of \$100 or so.

New in this edition are micro-fabricated gyroscopes and microphone elements, the latter of which is already appearing in consumer devices. The second edition updates modernize what was already an excellent book. I'd recommend that if you're not sure about spending the money on the book that

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